



10-16-08

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Docket No. 55220/844

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicants : Shoji Miyazaki et al.  
Appl. No. : 10/809,217  
Filed : March 25, 2004  
For : BIOSENSOR, THIN FILM ELECTRODE FORMING METHOD,  
QUANTIFICATION APPARATUS, AND QUANTIFICATION  
METHOD  
Customer No. : 1912  
Examiner : Alexander Stephan Noguera  
Art Unit : 1795

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**  
**PURSUANT to 37 C.F.R. §1.97(b)(3)**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

"Express Mail" mailing label No.	EM 163835389 US
Date of Deposit:	October 14, 2008
I hereby certify that this paper or fee is being deposited with the United States Postal Service "Express Mail" service under 37 CFR 1.10 on the date indicated above and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.	
Name:	Jeffrey C. Shieh
Signature:	

This Information Disclosure Statement is being filed to supplement the Information Disclosure Statements filed on March 25, 2004, April 16, 2007 and August 15, 2008 in connection with the above-identified application.

In accordance with the duty of disclosure under 37 C.F.R. §1.56, applicants would like to direct the Examiner's attention to the references that are listed on Form PTO/SB/08A (1 page) and attached hereto.

Applicants note that submitted references PCT International Patent

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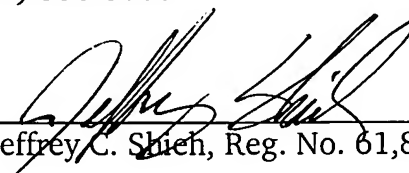
Publication No. WO 97/02487 and Japanese Published Patent Application No. 5-505459 are references cited in an Office Action issued in connection with a Japanese priority application (Japanese Patent Application No. 2000-111255). Applicants note that Japanese Published Patent Application No. 5-505459 is a national stage application of PCT International Patent Publication No. WO 91/09139.

Applicants are submitting this Information Disclosure Statement pursuant to 37 C.F.R. §1.97(b)(3) before the mailing of a first Office Action on the merits. Accordingly, no fee is deemed necessary in connection with the filing of this Information Disclosure Statement. However, if any fee is required in connection with the submission of this Information Disclosure Statement or to maintain the pendency of the subject application, authorization is hereby given to charge the amount of any such fee to Deposit Account No. 01-1785.

Respectfully submitted,

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Dated: October 14, 2008  
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By   
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